



Docket No.: 4249-0112P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kui YAO et al.

Application No.: 10/680,229

Confirmation No.: 5826

Filed: October 8, 2003

Art Unit: 1792

For: METHOD TO PRODUCE A RELIABLE
PIEZOELECTRIC THICK FILM ON A
SUBSTRATE

Examiner: Talbot, Brian K.

REQUEST FOR RECONSIDERATION

REPLY UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 6, 2009

Sir:

In response to the Final Office Action mailed April 3, 2009, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes

**Listing of Pending Claims (No Changes) and
Remarks.**